

<i>Notice of References Cited</i>	Application/Control No. 10/519,858		Applicant(s)/Patent Under Reexamination HAYASHI ET AL.	
	Examiner ZHIYU LU		Art Unit 2618	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,058,141	10-1991	Kem et al.	375/368
*	B	US-2002/0030597	03-2002	Muirhead, Scott A. W.	340/572.1
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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